

JSR ELPAC™ PID series

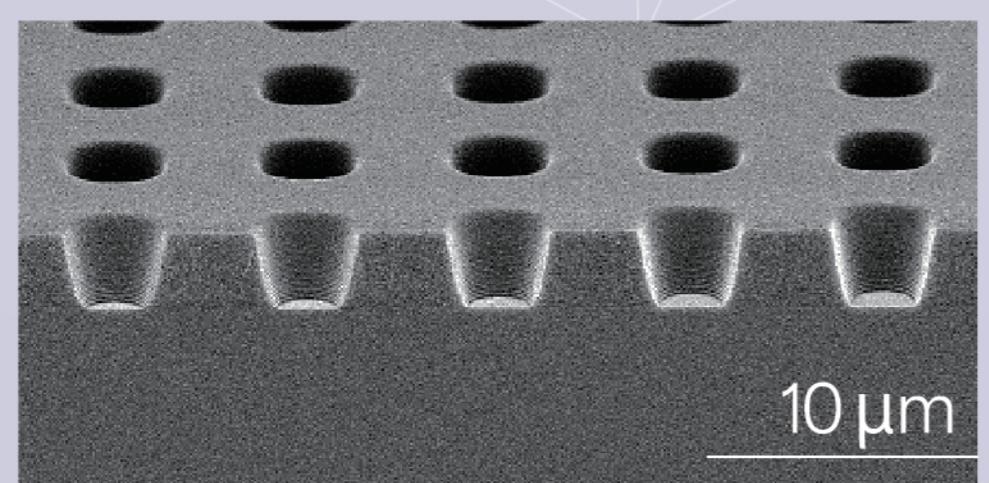
Photo-Imageable Dielectric (PID)

WPR Series / PFAS Free

Common Features

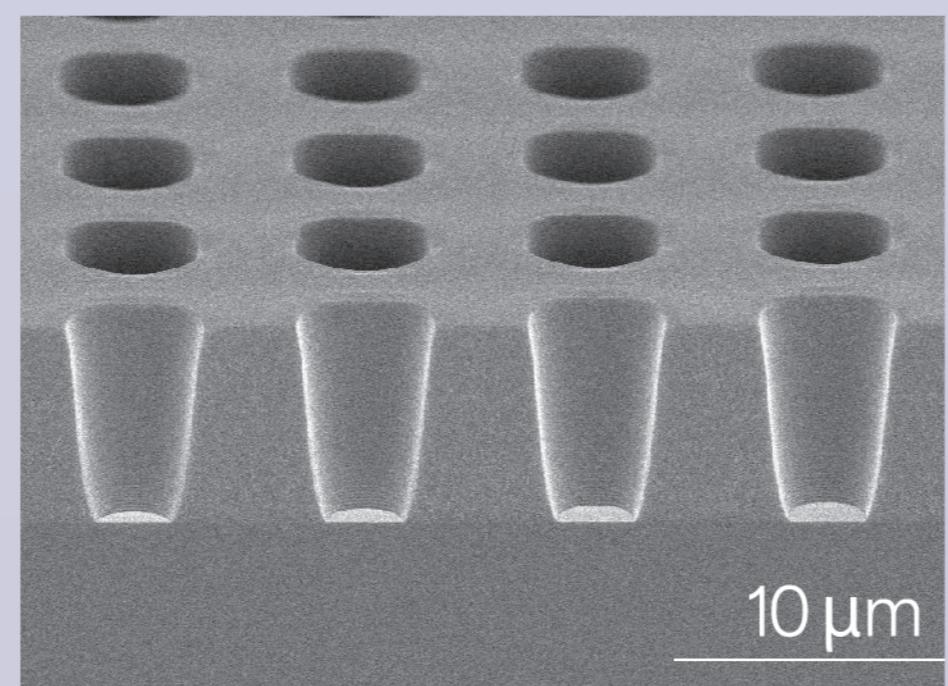
High resolution
Good adhesion
Low cure temperature

FT = 2 ~ 3 μm



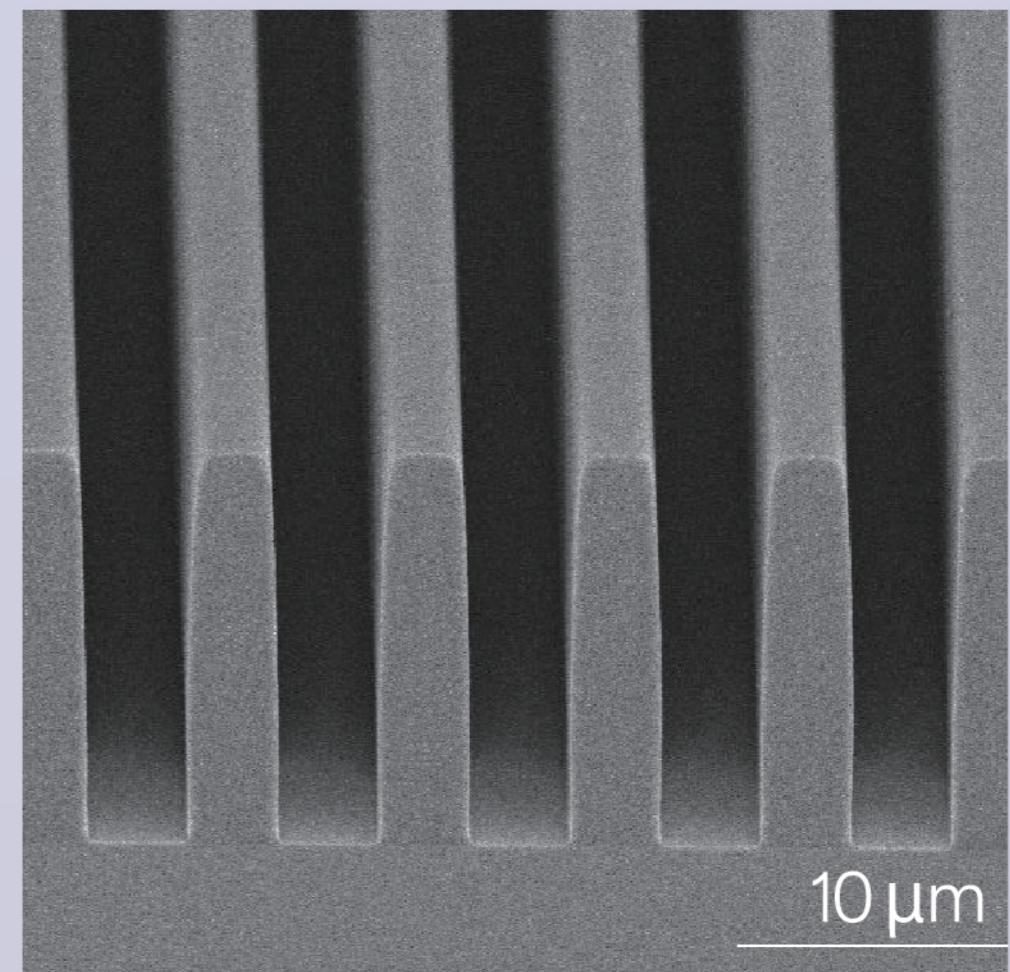
2 μm-SQ

FT = 5 ~ 10 μm



2.5 μm-SQ

FT = 10 ~ 20 μm



4 μm-L/S

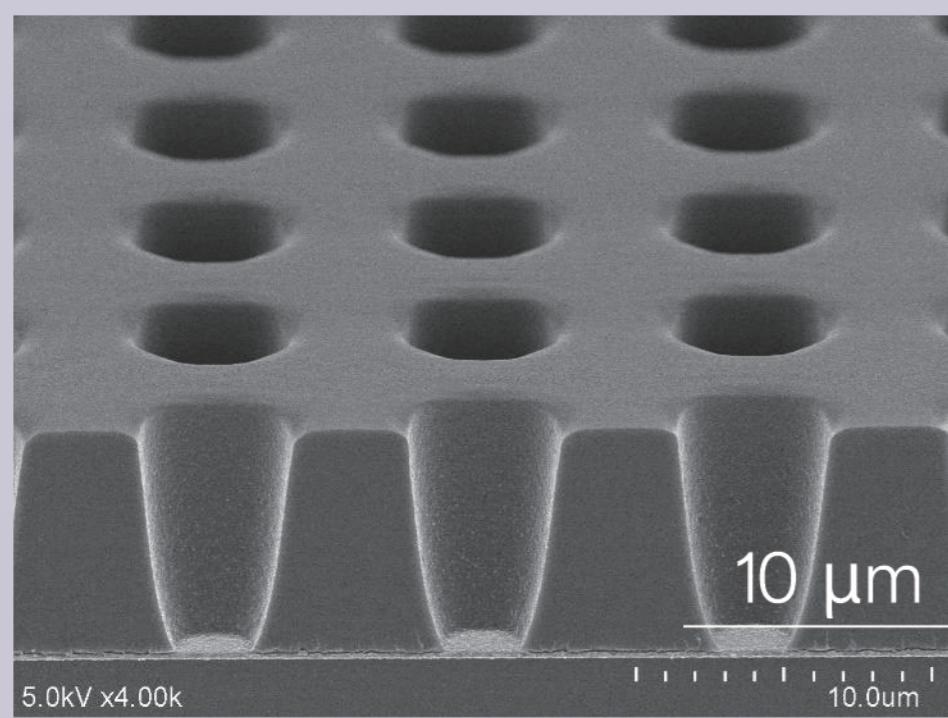
Positive-tone

- ✓ Photo-sensitivity for ghi-line
- ✓ Ideal taper profile

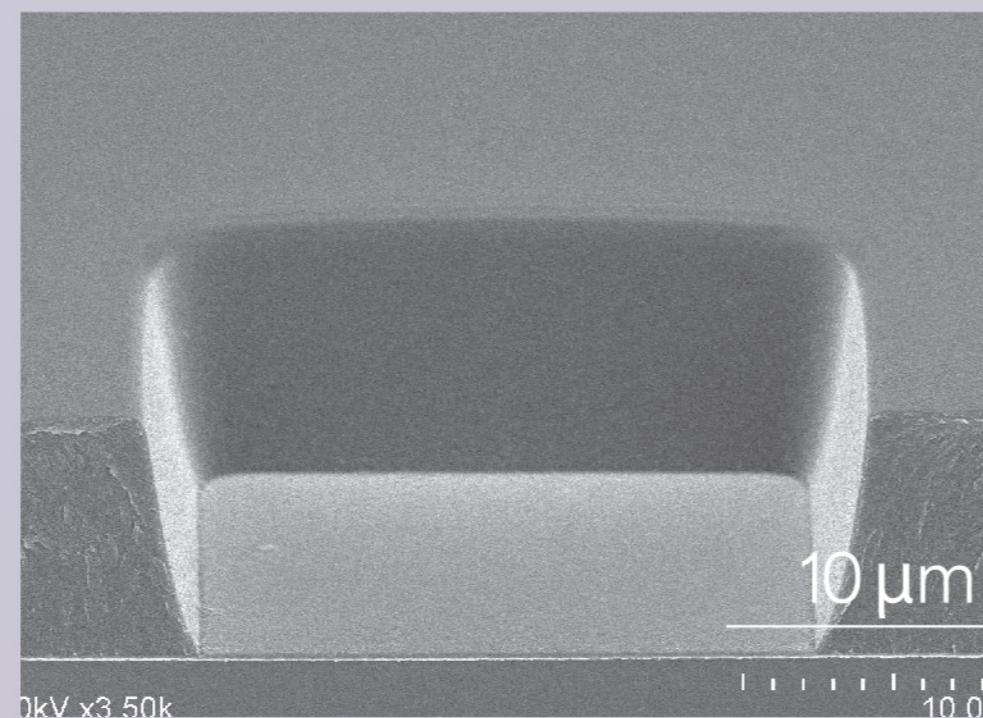
Negative-tone

- ✓ Thick patterning
- ✓ Low warpage

PI Series / PFAS Free - Under development



2.5 μm-SQ

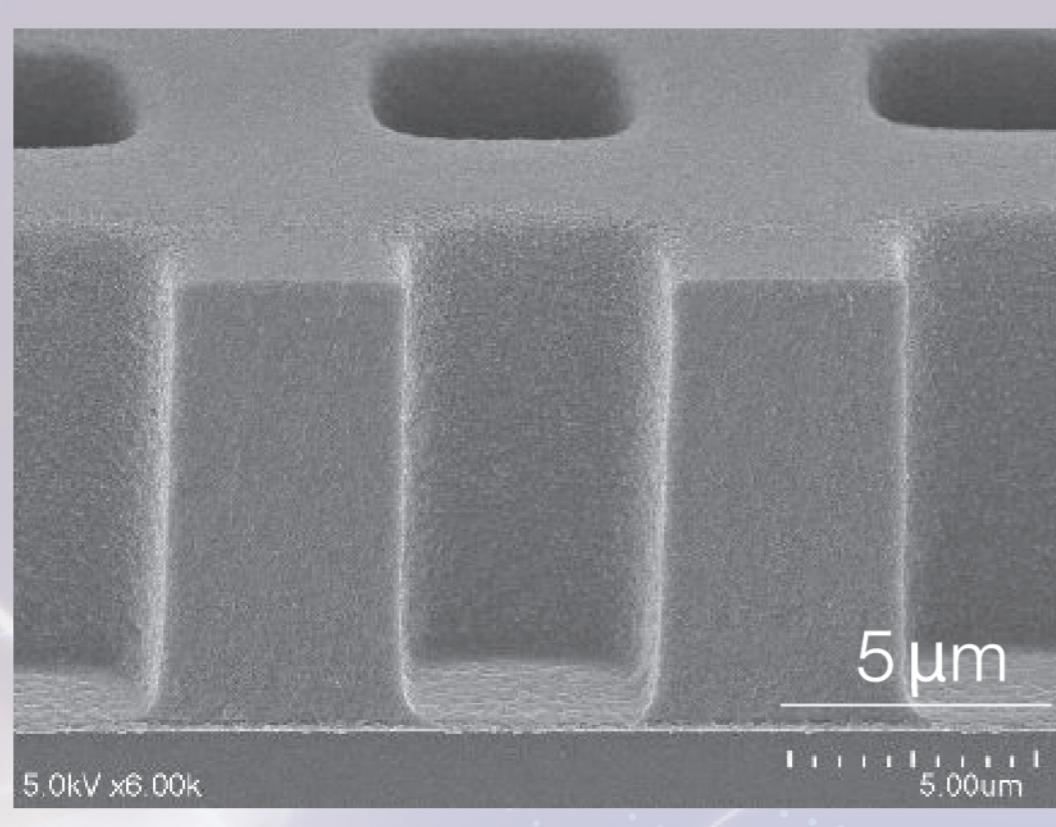


20 μm-SQ

Positive-tone

- ✓ Low cure temperature ($\leq 200^{\circ}\text{C}$)
- ✓ Good elongation (>60 %)
- ✓ High Tg (330 °C)

Dry film PID - Under development



5 μm-SQ

Negative - tone

- ✓ Dry film for advanced substrate
- ✓ Low CTE (31 ppm/K)
- ✓ Good Cu peel strength (0.4 N/mm)

